



Practitioner's Docket No. 101109.0003US1

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Liu, Heng

Application No.: 10/621,049

Filed: July 15, 2003

For: Chemical Vapor Deposition Reactor

Group No.: 1763

Examiner:

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

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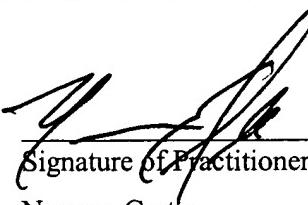
The information disclosure statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of a first Office action on the merits, whichever event occurs last. 37 C.F.R. § 1.97(b).

Date: 20 Jun 04

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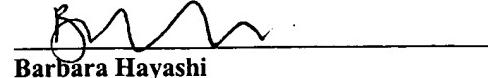
US

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Date: 1/20/04

  
Barbara Hayashi

<b>LIST OF REFERENCES CITED BY APPLICANT</b> <i>(Use several sheets if necessary)</i>	ATTY. DOCKET NO.	SERIAL NO.
	101109.0003US1	10/621049
	APPLICANT	
	Heng Liu	
FILING DATE	GROUP	
July 15, 2003	1763	

*JAN 23 2004*

U.S. PATENT AND TRADEMARK OFFICE

#### U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	4961399	10/9/1990	Frijlink			
	BB	6113705	9/5/2000	Ohashi, et al.			
	CC	6197121	3/6/2001	Gurary, et al.			
	DD	6080241	6/21/2000	Li et al.			
	EE	4980204	12/25/1990	Fujii, et al.			
	FF						
	GG						
	HH						
	II						

#### FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	JJ							
	KK							
	LL							
	MM							
	NN							

#### OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

OO	
PP	
QQ	

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.